Searcn Notes				

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/618,541	HWANG	
Examiner	Art Unit	
Richard H. Kim	2871	

SEARCHED			
Class	Subclass	Date	Examiner
		·	
			(1)

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
		·····	

SEARCH NOT (INCLUDING SEARCH		·)
	DATE	EXMR
East Search (jpo,epo,uspat,pgpub)	12/26/2007	RHK
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